

<b>Notice of References Cited</b>	Application/Control No. 10/732,899	Applicant(s)/Patent Under Reexamination TAKIZAWA ET AL.	
	Examiner Mike Qi	Art Unit 2871	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,906,765 B2	06-2005	Narutaki et al.	349/106
	B	US-6,785,068 B2	08-2004	Takizawa et al.	359/885
	C	US-			
	D	US-			
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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